JC20 F PCT/PTO 11 MAY 2005, 2

94326

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re U.S. Pater	nt Application	)
Applicant:	Takashi YOKOYAMA et al.	)
Serial No.:	Unassigned	)
Filed:	May 11, 2005	)
For:	SILICON WAFER, ITS MANUFACTURING METHOD,	)

## INFORMATION DISCLOSURE STATEMENT

Mail Stop PCT Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313

Sir:

Pursuant to 37 C.F.R. §1.97, a list of documents is disclosed on the attached Form PTO-1449 that may be material to the examination of this application. The cited references are enclosed herewith.

Documents for which the supplied date of publication lists the year of publication without the month were published sufficiently earlier than the effective U.S. filing date and any foreign priority date, so that the particular month of publication is not in issue. Pursuant to §609 of the MPEP, it is understood that the month of publication is not required when the particular month of publication is not in issue.

No inferences should be drawn that the attached list represents a comprehensive investigation, or that any material disclosed is equivalent to the subject invention. In addition, none of the documents that have publication dates prior to the priority date of the above application anticipate the invention in this application.

Applicant also encloses a copy of the PCT Search Report and references cited therein.

The cited document(s) disclose numerous specific features. There has been no attempt to list each

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and every feature disclosed by each document. The Examiner is requested to review the document(s) and determine the extent of the materiality of the document disclosures with respect to the present invention.

The discussion of any art and the citation of any document(s) herein is not to be construed as an admission that the art or document disclosure is necessarily within the invention field of endeavor, that the art or document disclosure is necessarily prior in time to a particular date which may be relevant to the instant patent application, and/or that the art or document disclosure is otherwise necessarily prior art as defined by the patent law with respect to the instant invention and application.

Also, there is reserved the right to later set forth how the instant invention is distinguished over the disclosure of any document or other art, including the disclosures of the art and document(s) recited herein, that may be cited by the Examiner in rejecting a claim in the instant patent application. The recitation herein of the art and document(s) is not to be construed as an assertion that more pertinent art could not possibly be in existence.

Respectfully submitted,

Gerald T. Shekleton

Registration No. 27,466

Dated: May 11, 2005

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT			OCUPE	Application Number	Inassigner 54946	
				Filing Date	May 11, 2005	
			PLICANT	First Named Inventor	YOKOYAMA et al.	
(use as many sheets as necessary)				Art Unit	Unassigned	
			necessary)	Examiner Name	Unassigned	
Sheet	1	of	1	Attorney Docket Number	94326	
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U.S. PATENT DOCUMENTS						
Examin er Initials*	Cite No.1	Document Number  Number-Kind Code <sup>2 (if known)</sup>	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear	
				4 444		
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FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No.1	Foreign Patent Document Country Code <sup>3</sup> -Number <sup>4</sup> -Kind Code <sup>5</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	Te
		JP 2001-278692	10/10/2001	Ryoji et al.		Abstract
		JP 61-193456	08/27/1986	Kikuo et al.		Abstract
.,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,		JP 2001-102385	04/13/2001	Kazuhiro et al.		Abstract
		JP 3-279290	12/10/1991	Shinichi		Abstract

	NON PATENT LITERATURE DOCUMENTS				
Examiner Initials*	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	1e		
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